



4-12073
Docket No.: M4065:0227/P227
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tongbi Jiang, et al.

Application No.: 09/652,216

Group Art Unit: 2812

Filed: August 30, 2000

Examiner: Not Yet Assigned

For: METHOD AND APPARATUS FOR
REDUCING SUBSTRATE BIAS VOLTAGE
DROP

SUBMISSION OF FORMAL DRAWINGS

Commissioner for Patents
Washington, DC 20231

Dear Sir:

Submitted herewith is one set (six sheets, 1-6 figures) of formal drawings for filing in the above-identified patent application. Kindly substitute the enclosed formal drawings for the informal drawings submitted with the originally filed application.

Dated: April 4, 2001

Respectfully submitted,

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